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10/748,828

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Application Number

OVERRANSMITTAL		Filing Date	December 29, 2003
S\FQDM		First Inventor	Han-Hsing Liu
APR 2 6 2005		Confirmation No.	7167
, Ø		Group Art Unit	2829
(to be used for all correspondence after initial filing)		Examiner Name	Renee R. Berry
Total Number Of Pages In Th	is Submission 7	Attorney Docket No.	DAF009 US
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Fee Attached Credit Card Payment Form (1 pg)		rawing(s)	Appeal Communication to Board of Appeals and Interferences
Amendment / Re	eply (6 pages)	censing-related Papers	Appeal Communication to Group (Appeal Notice, Brief, Reply Brief)
After Final		etition	Proprietary Information
Affidavits/declarations P		etition to Convert to a ovisional Application	Status Letter
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Firm	Michael J. Halbert (Reg. No. 40,633)		
or Silicon Valley Patent		roup LLP	
2350 Mission College			
Santa Clara, California 95054			
Signature This Grant Gra			
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4-28-05



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors:

Han-Hsing Liu

Assignee:

Winbond Electronics Corporation

Title:

Polycide Gate Stucture and Manufacturing Method Thereof

Serial No.:

10/748,828

Filing Date:

December 29, 2003

Examiner:

Renee R. Berry

Group Art Unit:

2829

Docket No.:

DAF009 US

Confirmation No.:

7167

Santa Clara, California April 26, 2005

Mail Stop Amendment Commissioner For Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Dear Sir:

This Response to Office Action is responsive to the January 26, 2005, Office Action, which has a statutorily shortened period for response that ends April 26, 2005. Please enter the following amendments before taking action on the merits of the above-referenced application.

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